

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Glenn Houser

Application No.: 10/625,830

Filed: July 22, 2003

For:

METHOD AND APPARATUS FOR MEASUREMENT OF WAFER OR

FILM THICKNESS

MAIL STOP AMENDMENT

Group Art Unit: 2877

Examiner: Richard A. Rosenberger

Confirmation No.: 8963

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 10, 2006, please amend the above-identified patent application as follows:

Comments regarding the Claims begin on page 2; and Remarks begin on page 8.